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*Stamp:* PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re application of:** Basceri et al.

**Application No.** 09/965,509

**Filed:** September 26, 2001

**Confirmation No.** 3307

**For:** METHODS FOR FORMING AND  
INTEGRATED CIRCUIT STRUCTURES  
CONTAINING ENHANCED-SURFACE-  
AREA CONDUCTIVE LAYERS

**Examiner:** Toniae M. Thomas

**Art Unit:** 2822

**Attorney Reference No.** 6047-59403

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**CERTIFICATE OF MAILING**

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney  
for Applicant(s) *[Signature]*

Date Mailed October 8, 2003

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT  
PURSUANT TO 37 C.F.R. § 1.97(c)**

Listed on the accompanying form PTO-1449 and enclosed herewith are several English-language documents. Applicants respectfully request that these documents be listed as references cited on the issued patent. This Information Disclosure Statement ("IDS") is being mailed before Applicants received a final action, a notice of allowance, or an action that otherwise closes prosecution in the referenced application.

Submitted herewith is a check for \$180.00 as required by 37 C.F.R. § 1.17(p) for filing this IDS in compliance with 1.97(c).

Please charge any additional fees which may be required in connection with filing this IDS, or credit any overpayment, to Deposit Account No. 02-4550. A duplicate copy of this sheet is enclosed.

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The filing of this IDS shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

Respectfully submitted,

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				<b>Attorney Docket Number</b>	6047-59403
				<b>Application Number</b>	09/965,509
				<b>Filing Date</b>	September 26, 2001
				<b>First Named Inventor</b>	Basceri
				<b>Art Unit</b>	2822
				<b>Examiner Name</b>	Toniae M. Thomas
<b>U.S. PATENT DOCUMENTS</b>					
<b>Examiner's Initials*</b>	<b>Cite No. (optional)</b>	<b>Number</b>	<b>Date</b>	<b>Name</b>	
		6,458,651	10/2002	Rhodes	
		5,834,357	11/1998	Kang	
<b>OTHER DOCUMENTS</b>					
		Murakami, Y., et al. "Porous ruthenium oxide electrode prepared by adding lanthanum chloride to the coating solution," <u>Journal of Alloys and Compounds</u> , 261:176-181 (1997).			

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<b>EXAMINER SIGNATURE:</b>	<b>DATE CONSIDERED:</b>
* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.	